



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

the application of

: Confirmation No. 3771

Yoichiro NUMASAWA et al.

: Attorney Docket No. 2003_1106A

Serial No. 10/642,619

: Group Art Unit 1754

Filed August 19, 2003

: Examiner Ngoc Yen M. Nguyen

APPARATUS AND METHOD FOR
MANUFACTURING HALOGEN GAS
AND HALOGEN GAS RECOVERY
AND CIRCULATORY SYSTEM

: Mail Stop: Amendment

RESPONSE TO RESTRICTION/SPECIES ELECTION REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Restriction/Species Election Requirement dated September 13, 2005, the period for response having been extended for five months extension by the attached petition, Applicants hereby elect Group I, claims 1-7, drawn to a process for manufacturing halogen gas.

Applicants further elect A_iX_j as the species of gas used as the starting material for I and Si as the species for "A". It is respectfully submitted that at least claims 1, 2 and 5-7 are readable on the elected species.

Favorable action on the merits is solicited.

Respectfully submitted,

Yoichiro NUMASAWA et al.

By:


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THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

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